

SKYLARK 780 NX

SINGLE FREQUENCY CW DPSS NIR LASER

The Skylark 780 NX CW DPSS laser delivers single frequency operation, powering rubidium applications with up to 400 mW of ultra-stable output.

Low ASE noise and narrow linewidth provide exceptional spectral purity, ensuring precision and performance.



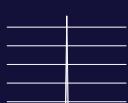
Key features



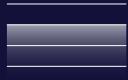
Ultra-narrow linewidth
≤ 300 kHz



Ultra-low power noise
≤ 0.3 % RMS (10 Hz - 10 MHz)



Ultra-low ASE noise
< - 80 dB



Ultra-stable power output
≤ 2.0 % over 8 hours



External frequency locking available

Applications

Raman spectroscopy, optical manipulation, rubidium D2 transitions, cold atom trapping, atomic spectroscopy, magnetometry, atom interferometry, Bose-Einstein Condensates (BEC formation), magneto-optical traps, frequency comb generation, atomic clocks, free-space optical communication.

Dimensions

Laser head (L x W x H)	257 x 150 x 87 mm
Beam height	54.2 mm

Reveal the unseen,
detect the imperceptible,
measure the unknown.



Specifications

Output beam parameters

Output power	up to 400 mW
Wavelength	780 nm
Spectral bandwidth	≤ 300 kHz
Spatial mode	TEM ₀₀
Spectral stability	± 0.2 pm (over 8 hour operation)
Coherence length	> 100 m
Output power stability	≤ 2.0 % (over 8 hour operation)
Output power noise	≤ 0.3 % RMS (10 Hz – 10 MHz)
ASE noise	< - 80 dB
Beam divergence	1.0 mrad, diffraction limited
Beam diameter at output aperture	0.8 - 1.2 mm
Beam pointing stability	≤ 5 µrad/°C

Absolute referencing and fine tuning

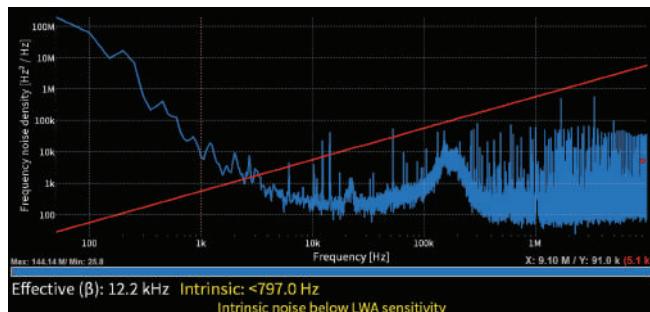
Wavelength is fixed between ~775 – 815 nm and locked using a temperature-controlled reference etalon.

The laser can be locked to an external atomic reference using feedback from an error signal. Fine tuning is achieved via a piezo element with a tuning range of 1 GHz.

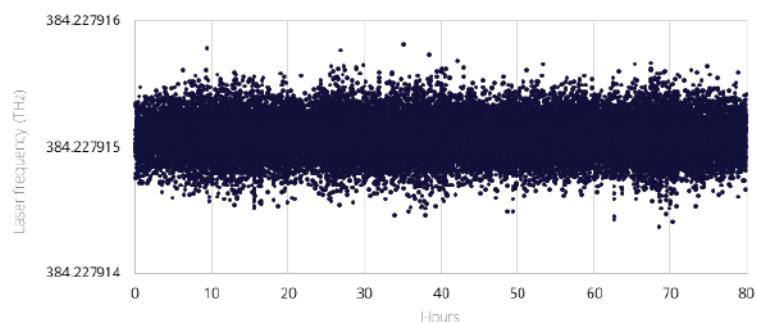
For greater adjustment (e.g. to reach different hyperfine transitions), the reference etalon can be adjusted, offering an extended range of ~40 GHz.

Environmental conditions

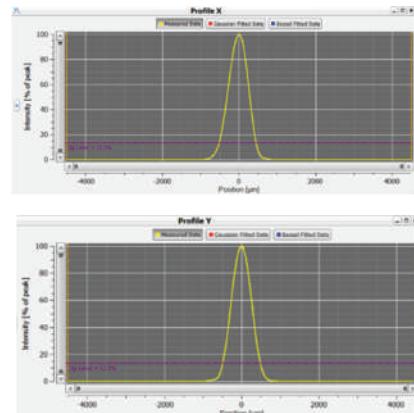
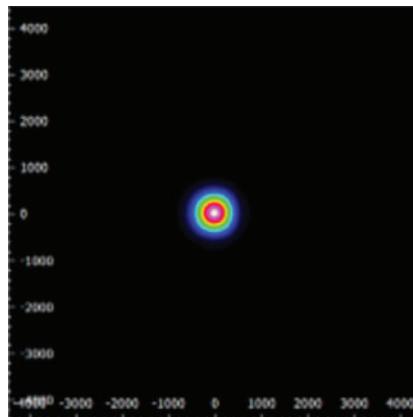
Ambient temperature range	18 - 30 °C
Laser head interface stability	± 1.5 °C
Storage	0 - 50 °C
Humidity	0 - 50 %, non-condensing



Unlocked / passive linewidth measured as 12.2 kHz over 1 ms

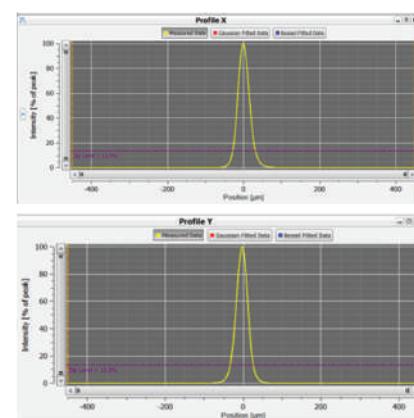
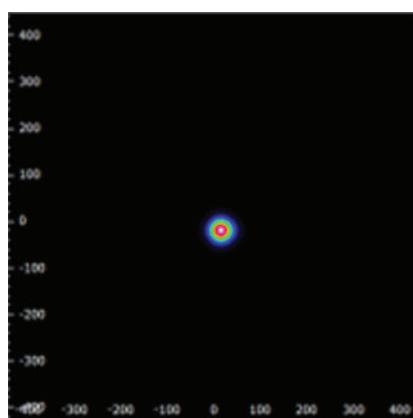


Laser lock to relevant cooling and repump absorption lines over 80 hours.
The lock is robust to mechanical and thermal fluctuations.



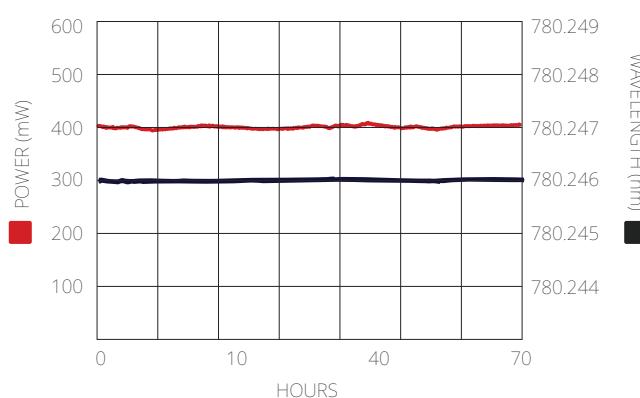
Near-field beam profile | Ellipticity 100%

Calculation Results		
Parameter	Value	Unit
Calculations Derived from Raw Data		
Beam Width (4-Sigma) X	952.8	μm
Beam Width (4-Sigma) Y	950.9	μm
Centroid Position X	-20.9	μm
Centroid Position Y	-4.3	μm
AD Saturation	67.5	%
Ellipse (fitted)		
Ellipticity	100.0	%
Profile Measurement		
Beam Width Clip X (13.5%)	967.5	μm
Beam Width Clip Y (13.5%)	972.0	μm
Fit Measurement		
Gaussian Diameter X	932.0	μm
Gaussian Diameter Y	931.9	μm

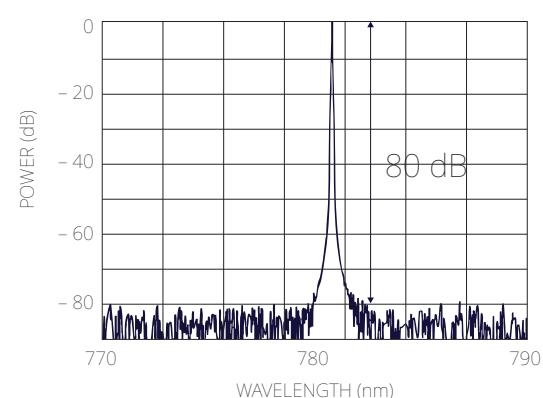


Far-field beam profile | Ellipticity > 98%

Calculation Results		
Parameter	Value	Unit
Calculations Derived from Raw Data		
Beam Width (4-Sigma) X	62.9	μm
Beam Width (4-Sigma) Y	61.7	μm
Centroid Position X	1.1	μm
Centroid Position Y	-3.1	μm
AD Saturation	74.0	%
Ellipse (fitted)		
Ellipticity	98.2	%
Profile Measurement		
Beam Width Clip X (13.5%)	59.5	μm
Beam Width Clip Y (13.5%)	58.9	μm
Fit Measurement		
Gaussian Diameter X	60.2	μm
Gaussian Diameter Y	59.2	μm



780 NX power and wavelength stability over 70 hours



ASE noise < -80 dB